

L Number	Hits	Search Text	DB	Time stamp
10	14147	VCO	USPAT	2003/12/22 10:09
11	310	VCO and diffusion	USPAT	2003/12/22 10:09
12	2	VCO and diffusion and "p material"	USPAT	2003/12/22 10:09
13	1	VCO and diffusion and "p material" and CMOS	USPAT	2003/12/22 10:33
14	55381	CMOS	USPAT	2003/12/22 10:34
15	8	CMOS and "rectangular diffusion"	USPAT	2003/12/22 10:34
16	2	CMOS and "rectangular diffusion" and material and well	USPAT	2003/12/22 10:34
17	2	CMOS and "rectangular diffusion" and material and well and gate	USPAT	2003/12/22 10:34
18	2	CMOS and "rectangular diffusion" and material and well and gate and substrate	USPAT	2003/12/22 10:38
19	12246	CMOS and diffusion	USPAT	2003/12/22 10:38
20	8246	CMOS and diffusion and material	USPAT	2003/12/22 10:38
21	7279	CMOS and diffusion and material and well	USPAT	2003/12/22 10:38
22	6958	CMOS and diffusion and material and well and substrate	USPAT	2003/12/22 10:38
23	5987	CMOS and diffusion and material and well and substrate and gate	USPAT	2003/12/22 10:39
24	555	CMOS and diffusion and material and well and substrate and gate and polycide	USPAT	2003/12/22 10:43
25	0	CMOS and diffusion and material and well and substrate and gate and polycide and vco	USPAT	2003/12/22 10:39
26	0	CMOS and diffusion and material and well and substrate and gate and polycide and VCO	USPAT	2003/12/22 10:39
27	2	CMOS and diffusion and "p material" and well and substrate and gate and polycide	USPAT	2003/12/22 10:44